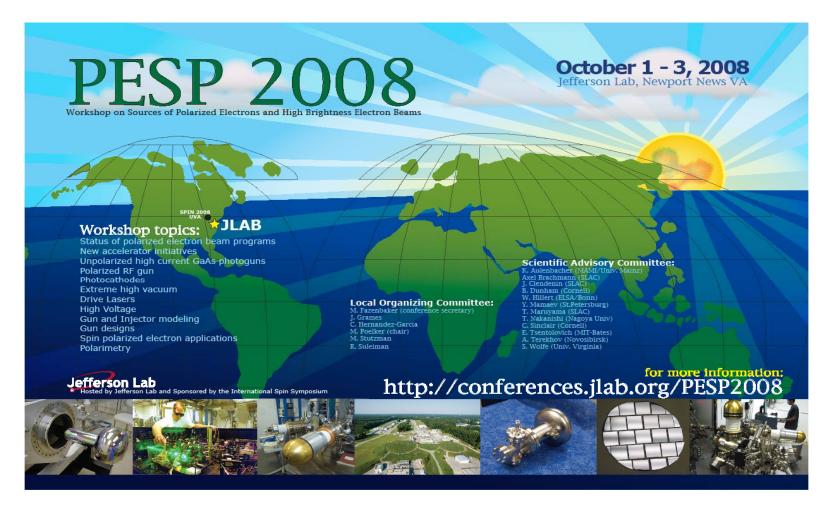
Short summary of PESP2008 F. Zhou (SLAC)



Note: I 'borrowed' most slides from Matt Poelker, who prepared them for SPIN08

Programs of PESP2008

- Polarized e-Beam Programs with focus on NEW and proposed machines
- Photocathodes: High Polarization, novel structure, obtaining longer lifetime
- Very High Voltage DC Guns (voltage >>100kV)
- RF and SRF guns with focus on polarized and CW
- Drive lasers
- Vacuum
- Polarimetry

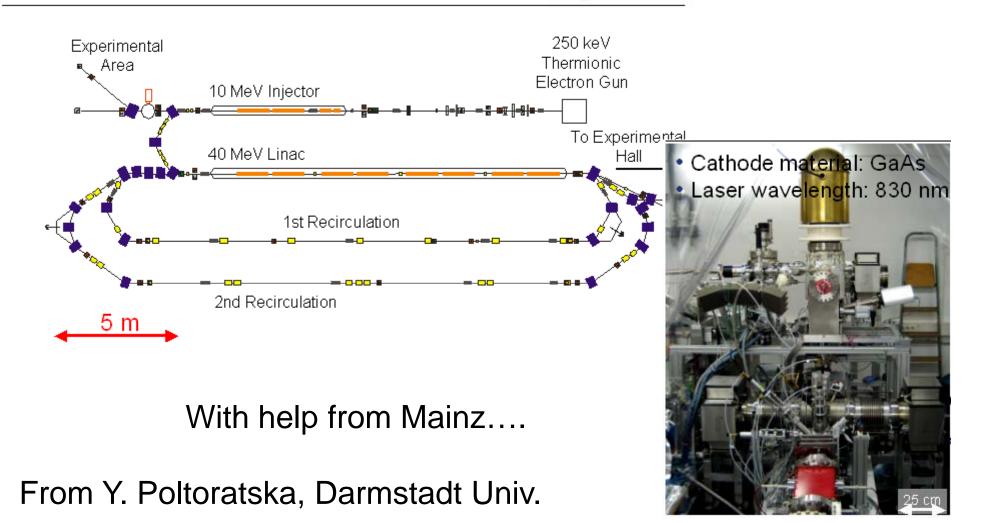
~80 registered attendees, 37 talks.

NEW Polarized e-Beam Facility

TECHNISCHE

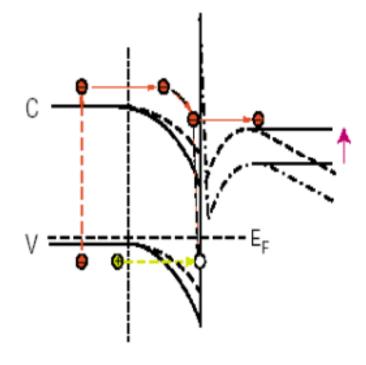
UNIVERSITĂT DARMSTADT

S-DALINAC Polarized Injector ("SPIN")

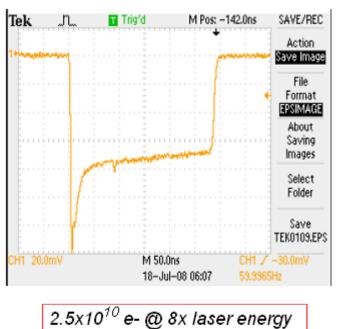


Proposed polarized facilities: ILC and CLIC

ILC and CLIC: High Bunch Charge, High Peak Current and "new" time structure compared to SLC. R&D Issues: Space Charge and Surface Charge Limit.



From F. Zhou, SLAC



10 mm full size

Proposed polarized facilities: **Electron Ion Collider**

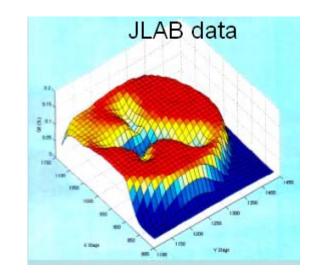
eRHIC (Linac-ring version)

Requires a polarized electron source with an extremely high current

Luminosity ~ $2.6 \cdot 10^{33} \text{ cm}^{-2} \text{s}^{-1} \implies \text{I}(\text{average}) \sim 250 \text{ mA}$

Residual Gas leads to Ion Back-Bombardment and QE decay and short lifetime:

- Improve Vacuum
- Large laser spot
- Higher gun voltage
- More rugged photocathodes
- Better beam management



Slide from E. Tsentalovich, MIT-Bates

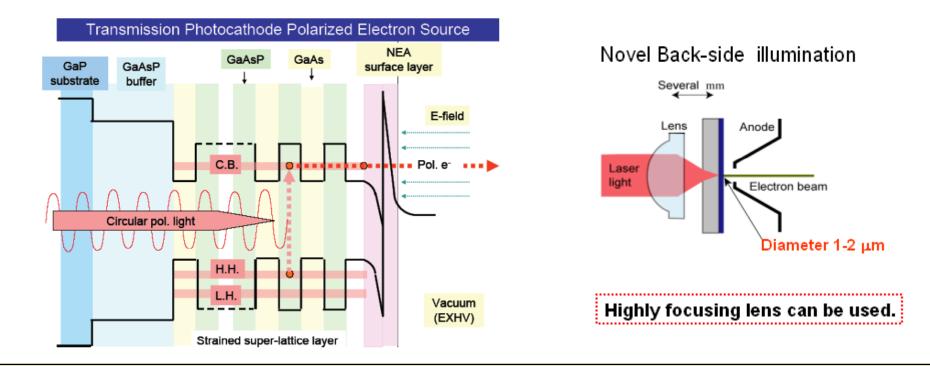
Polarized photocathodes

Best photocathodes

					Exceptional
Sample	Composition	P _{max}	$QE(\omega_{max})$	Team	modeling helps
SLSP16	GaAs(3.2nm)/ GaAs _{0.68} P _{0.34} (3.2nm)	92%	0.5%	Nagoya University, 2005	identify
					depolarization
SL5 -777	GaAs(1.5nm)/	91%	0.14%	SPbSPU, 2005	mechanisms
	In _{0.2} Al _{0.23} Ga _{0.57} As(3.6nm)				Working on
SL7-307	Al _{0,4} Ga _{0,6} As(2.1nm)/ In _{0,19} Al _{0,2} Ga _{0,57} As(5.4nm)	92%	0.85%	SPbSPU, 2007	reflective back surface to boost QE

From L. Gerchikov. State Polytechnic Univ. St. Petersburg Samples grown at loffe Technical Institute, St.Petersburg

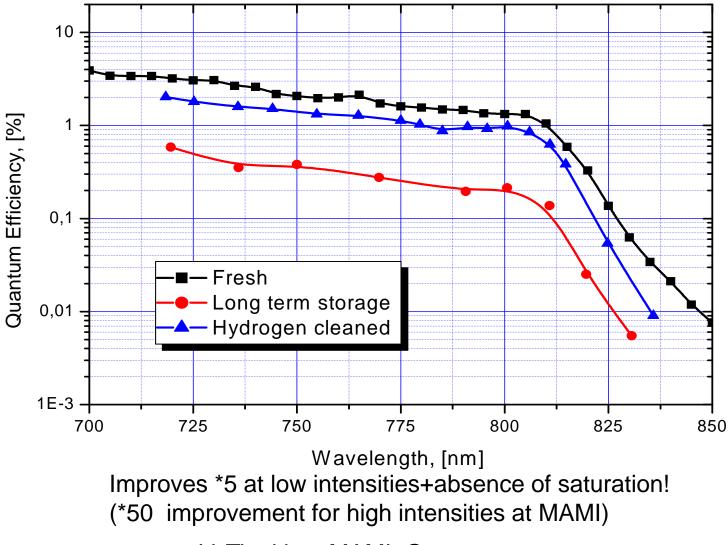
Polarized photocathodes



Back-illuminated High Polarization (~ 90%) and High Brightness Photocathode, built for materials science, but could be used for accelerator applications with extremely low emittance requirement

Excellent work reported by T. Ujihara, X. Jin, N. Yamamoto, T. Nakanishi, Nagoya University

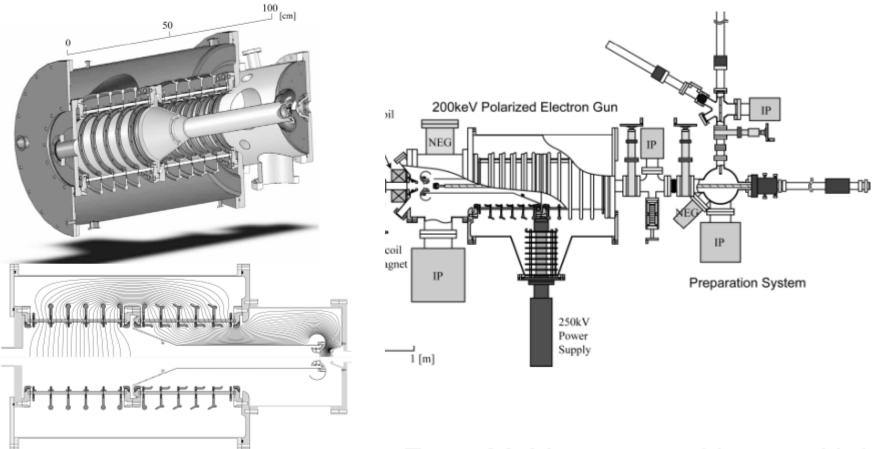
Polarized photocathode: Atomic hydrogen cleaning



V. Tioukine, MAMI, Germany

Very High Voltage DC Guns (polarized)

200kV Gun, load lock gun with segmented insulator and high polarization GaAs photocathode



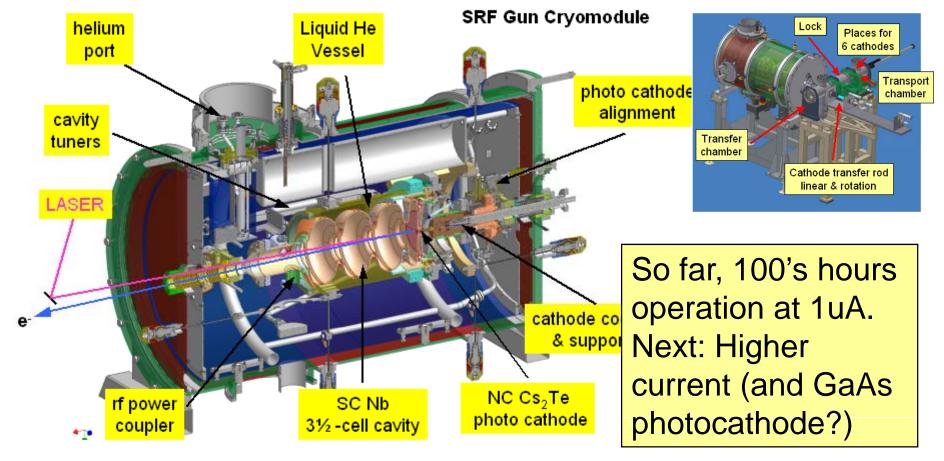
From M. Yamamoto, Nagoya Univ.

Very high voltage DC gun (unpolarized)

- JLAB-FEL project: design 500kV but typical operation at 330kV; field emission can lead to catastrophic insulator "punch-through (C. Hernandez-Garcia).
- ASTeC-Daresbury: 350 kV; field emission not problematic but repeated mechanical failures at ceramic-to-flange joint...(L. Jones)
- Cornell: design 750 kV but Field emission and "punch through" limits voltage to ~ 300kV (K. Slomenski).
- JAEA: 250 kV; working on 500kV version with segmented insulator (N. Nishimori).

SRF Gun (unpolarized)

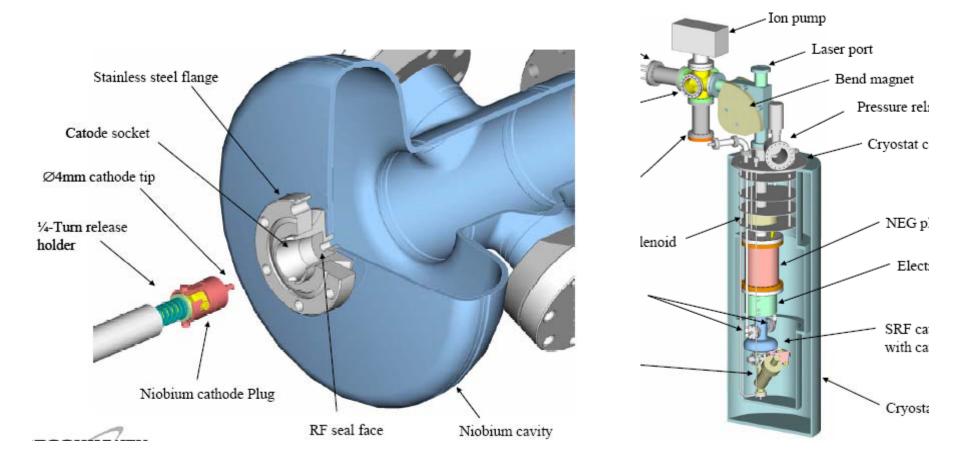
Holy Grail of e-guns: Perfect vacuum, High Average Current, High Brightness, Low RF Power



From J. Teichert, A. Arnold, FZD Dresden-Rossendorf

SRF Gun under development (polarized)

Polarized SRF Gun at BNL: for ILC, eRHIC and ERLs

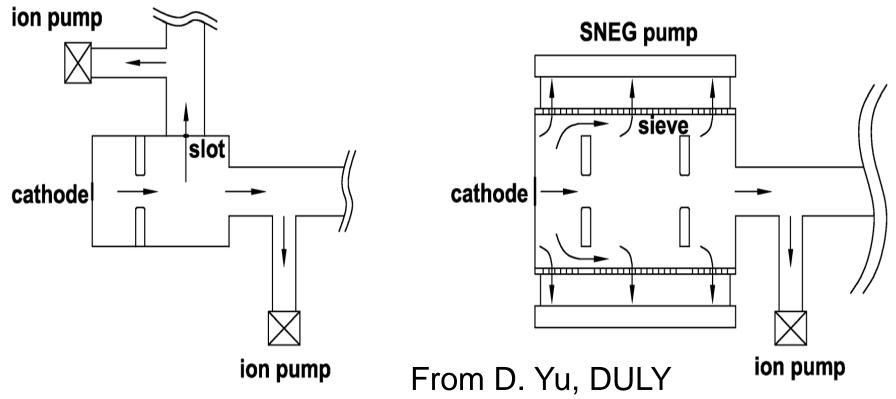


From D. Holmes, AES and J. Kewisch, BNL

PWT N.C. RF gun under development (polarized)

Vacuum Pumping Paths

1.6-cell Gun (left) and PWT Gun (right)



Summary of R&D Projects

- Reliable trouble-free DC high voltage gun operation beyond 300kV (eliminate field emission, improved insulator design)
- Understanding (and eliminating) Surface Charge Limit (the phenomenon of reduced QE at high laser power)
- Develop rugged photocathodes with improved lifetime
- Back-illuminated, transmission-style photocathodes
- Achieve better vacuum, 10⁻¹² Torr and below
- SRF gun technology BNL (and Rossendorf?) to demonstrate operation with GaAs...